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**APPLICATION FOR LETTERS PATENT:**

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**HOTSPOT COLDPLATE SPRAY COOLING SYSTEM**

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## **HOTSPOT COLDPLATE SPRAY COOLING SYSTEM**

### **CROSS REFERENCE TO RELATED APPLICATIONS**

**[0001]** We hereby claim benefit under Title 35, United States Code, Section 120 of United States patent application Serial Number 10/260,713 filed September 27, 2002 entitled "Thermal Management System for Evaporative Spray Cooling". This application is a continuation-in-part of the 10/260,713 application. The 10/260,713 application is currently pending. The 10/260,713 application is hereby incorporated by reference into this application.

### **STATEMENT REGARDING FEDERALLY SPONSORED RESEARCH OR DEVELOPMENT**

**[0002]** This invention was made with Government support under contract # F33615-03-M-2316 awarded by the Air Force Research Laboratory. The Government has certain rights in this invention.

## **BACKGROUND**

### **Field of the Invention**

**[0003]** The present invention relates generally to spray cooling thermal management systems and more specifically it relates to a coldplate spray cooling system that provides high heat evaporative cooling of electronic component hotspots.

### **Description of the Related Art**

**[0004]** Liquid cooling is well known in the art of cooling electronics. As air cooling heat sinks continue to be pushed to new performance levels, so has their cost, complexity, and weight. Liquid cooling is replacing air cooling and enabling the performance of electronics to grow exponentially.

**[0005]** A significant performance enhancing feature of liquid cooling relates to the possibility of cooling localized high heat flux zones, commonly referred to as hotspots. Electronic components create varying amounts of heat across their surfaces and a varying amount of heat as a function of time. Today's microprocessors, for example, may be constructed on a silicon die roughly 1 cm by 1 cm. As shown by Figure 2, The die may have multiple zones for different functions. Such zones may be for inputs and outputs (I/Os), level 1

cache, level 2 cache, and the core. The core may be roughly 0.5 cm by 0.5 cm and is where the main computer processing takes place. Although the core may be, but is not limited to, roughly only 25% of the total area of the die, the core creates almost the entire heat generation of the chip and may create a hotspot. Wherein a chip might be rated for an average heat load of 110 watts, with an average heat flux of 110 watts per centimeter squared, the core may generate 100 watts of that heat and have a heat flux of 400 watts per centimeter squared.

**[0006]** There are a number of different liquid cooling system styles. A first style is bare die. This method places a dielectric liquid coolant in direct contact with the die of a component to be cooled. Heat is directly transferred from the component to the fluid. Another style is referred to as coldplate cooling. This method uses a dielectric or non-dielectric cooling fluid contained within a housing. The housing is in direct contact with a component to be cooled and the fluid is indirectly thermally connected. Typically, a thermal interface material is sandwiched between the housing and the component package, but may also be between the housing and the component (no lid). Although bare die cooling is typically more efficient than coldplate cooling, primarily due to reduced thermal resistances between the fluid and the heat generating transistors, coldplate cooling provides a more flexible system capable of being used with standard chip packages. Coldplate cooling also provides the ability to use a wide range of cooling fluids. Both styles of liquid cooling styles may be used with single-phase and two-phase cooling systems.

**[0007]** Single-phase liquid cooling systems, such as U.S. Pat. No. 6,234,240, have a thermal management block containing a pure liquid. The thermal energy of the electronic component is transferred to the cooling liquid by means of sensible heat gains. The heat transfer rate of the system is equal to the heat transfer coefficient of the cooling fluid on the surface to be cooled, multiplied by the contact area, and further multiplied by difference in temperature between the contact surface and the cooling fluid. For low cost cooling system using ambient temperature cooling fluids, it can be easily seen that a heat transfer improvement requires a faster mass flow rate of the coolant, an increase in the heat transfer coefficient, or an increase in contact area. Even by the common single-phase practice of increasing the contact area by adding fins, pins and the like, single-phase thermal management blocks are unlikely to absorb anything above low-to-medium heat fluxes. Although low-to-medium heat fluxes across a multiple square inch contact area may equate to the overall heat generation rate of an electronic component, low-to-medium heat flux single-phase systems are not capable of localized performance required to cool component hotspots.

**[0008]** The preferred method of liquid cooling is two-phase cooling. With these systems, energy is absorbed by the cooling fluid as latent heat gains. Due to the increased energy required for a phase change in comparison to sensible heat gains, two-phase cooling systems offer the ability to provide more compact and higher performance cooling systems than single-phase systems.

**[0009]** An exemplary two-phase cooling method is spray cooling. Spray cooling uses at least one pump for supplying fluid to at least one nozzle that transform the fluid into droplets. These droplets impinge the surface of the component to be cooled and can create a thin coolant film. Energy is transferred from the surface of the component to the thin film. Because the fluid may be dispensed at or near its saturation point, the absorbed heat causes the thin film to turn to vapor. This vapor is then condensed, often by means of a heat exchanger, or condenser, and returned to the pump. A doctoral dissertation researched and authored by Tilton entitled "Spray Cooling" (available through the University of Kentucky library system, 1989), describes the physics behind spray cooling and the creation of thin evaporative films capable of absorbing heat in excess of 800 watts per centimeter squared. U.S. Pat. No. 5,220,804 discloses a wide area spray cooling system utilizing a vapor management protrusion.

**[0010]** Recently, the problem of cooling hotspots has led to new two-phase cooling technologies. One such technology is disclosed by U.S. Pat. No. 6,443,323, describing a method of variably cooling a computer component through the use of incremental sprayers. The incremental sprayers deposit fluid onto each zone at a mass flow rate necessary for complete phase change. Drops are ejected from an orifice in serial. Although this method improves the efficiency of the system, that is in attaining complete phase change of all dispensed fluid, the dispensing method does not provide spray characteristics

necessary to create high heat flux thin film evaporative cooling and high performance cooling of hotspots.

**[0011]** Another method of cooling hotspots is two-phase microchannels, such as described by U.S. Pat. No. 4,450,472. Although this method does not use spray cooling, the design does provide the ability to remove heat in the range of 400 -1000 watts per square centimeter using water. The system discloses a method of placing a very small microchannel array over a component. Although this method can effectively lower the temperature of the core, due to large pressure drops and resulting size limitations the method does not efficiently address the needs of the other areas of the die. In addition, this method does not efficiently cool multiple hot spots in separate parts of the die, such as multi-core processors.

**[0012]** For the foregoing reasons, there is a need for a liquid cooling solution that effectively cools the one or more hotspots of a computing component. Thus, there is a need for a localized cooling solution capable of large heat fluxes. Also, the high heat flux cooling system must efficiently and reliably cool the other non-high heat flux areas of the chip. The resulting cooling solution would allow significant improvements in processor performance.

## **BRIEF SUMMARY OF THE INVENTION**

**[0013]** In order to solve the problems of the prior art, and to provide a coldplate spray cooling solution capable of efficiently cooling hotspots, the present invention has been developed.

The present invention is a coldplate hotspot spray cooling system that cools an electronic component creating a varying amount of heat across its surfaces. Liquid coolant is dispensed upon a spray pin protruding from a base wherein the liquid creates a very high heat absorbing evaporative thin film. The spray pin is located over an area of the chip that produces a large heat flux, typically referred to as a hotspot. The small size and isolation of the spray pin provides the ability to generate very large heat fluxes. Multiple spray pins are possible.

**[0014]** These and other features, aspects, and advantages of the present invention will become better understood with regard to the following description, and accompanying drawings



## **BRIEF DESCRIPTION OF THE DRAWINGS**

**[0015]** In the course of the detailed description to follow, reference will be made to the attached drawings. These drawings show different aspects of the present invention and, where appropriate, reference numerals illustrating like structures, components, and/or elements in different figures are labeled similarly. It is understood that various combinations of the structures, components, and/or elements other than those specifically shown are contemplated and within the scope of the present invention:

**[0016]** Figure 1 is a block diagram of a spray cooling system;

**[0017]** Figure 2 is a top view of computer chip having a hotspot;

**[0018]** Figure 3, is a perspective view of a hotspot spray cooling system, according to the present invention, showing a spray module in direct contact with a component to be cooled;

**[0019]** Figure 4 is a section view of the spray module of Figure 3, cut through its mid-plane;

**[0020]** Figure 5 is a perspective exploded view of the coldplate system of Figure 3;

**[0021]** Figure 6 is a side view a spreader, including a spray pin according to the present invention, and showing liquid flow;

**[0022]** Figure 7 is a side view of an alternative embodiment of the spreader of Figure 6, including a vapor management protrusion;

**[0023]** Figure 8, is a perspective view of an alternative embodiment of the spreader of Figure 5, showing multiple spray pins of varying shapes and also including area enhancements; and

**[0024]** Figure 9, is a plot showing measured heat fluxes versus spray pin diameters.

## DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

**[0025]** Many of the fastening, connection, manufacturing and other means and components utilized in this invention are widely known and used in the field of the invention are described, and their exact nature or type is not necessary for a person of ordinary skill in the art or science to understand the invention; therefore they will not be discussed in detail.

**[0026]** Applicant hereby incorporates by reference the following U.S. patents: U.S. Patent No. 5,220,804 for a high heat flux evaporative cooling system; and U.S. Patent No. 5,860,602 and U.S. Patent No. 6,016,969, each for a laminated array of pressure swirl atomizers, and U.S. Patent No. 6,108,201 for a fluid control apparatus and method for spray cooling and U.S. Pat. Application No. 10/281,391 for an actuated atomizer.

**[0027]** Now referring to Figure 1, a closed loop two-phase spray cooling system 10 is shown. A liquid coolant (not shown) is pressurized by a pump 12. Preferably pump 12 is powered through the use of a direct current motor which creates accurate and precise pressures and flow rates. Pump 12 moves the cooling fluid to a series of system components via a tube system 18. Preferably tube system 18 is flexible and allows for variable three dimensional configurations. Tube system 18 should be made from a coolant compatible material.

**[0028]** The first system component downstream of pump **12** is a coldplate spray module **30**. Spray module **30** is in thermal contact with an electronic component **20** and it transforms the liquid coolant supplied to it into a mixture of liquid and vapor. The vapor is created from the liquid coolant absorbing energy from component **20**. The resulting liquid and vapor mixture is then delivered to a heat exchanger **16** wherein the vapor is condensed. The size of heat exchanger **16** can be minimized through the use of a liquid-vapor separator and by only delivering vapor to heat exchanger **16**. Liquid can be bypassed directly to pump **12**, or to a sub-cooler and then to pump **12**. A separator system is disclosed by co-pending application entitled "Hotspot Spray Cooling" also filed on February 24, 2004, and is incorporated herein by this reference. It should be appreciated to one skilled in the art that although only one spray module **30** is shown, more than one may be used within spray cooling system **10**.

**[0029]** Figure 2 shows electronic component **20**, as typically used in computing applications. The electronic component may be a computer processor, Field Programmable Gate Array (FPGA), Application Specific Integrated Circuit (ASIC), or any other commonly used electronic component. Electronic component **20** is electrically attached to a substrate **24** using any one of a wide range of commonly known interconnect technologies, including: ball grid array, pin grid array, land grid array, and wirebond. The present invention is not limited to any one particular interconnect method.

**[0030]** Electronic component **20**, of Figure **2**, is shown as a typical microprocessor. The top surface of component **20** has two zones, each with a unique function, unique power consumption, and thus, a unique heat generation rate. A hotspot **22**, where significant computations take place, generates high heat fluxes. The non-hotspot areas of component **20** generate lower heat fluxes. It should be appreciated that an electronic component may have multiple hot spots as areas of execution and floating point calculations may be done in separate locations.

**[0031]** Figures **3**, **4**, and **5** show spray module **30** according to the present invention. A substrate **24** may provide a planar surface for which to mount a socket **25**. Socket **25** may be any one of a number of widely used commercially available sockets, such as a Zero-Insertion-Socket (ZIF). Socket **25** houses electronic component **20** and maintains electrical contact between electronic component **20** and substrate **24**. It should be known to someone skilled in the art that electronic component **20** may be mounted directly to substrate **24** without the use of socket **25**.

**[0032]** Attached to the electronic component **20** is spray module **30**, which is comprised of a spreader **34**, a housing **33**, and a cap **32**. Spreader **34**, housing **33** and cap **32** may be fastened together through the use of sealants and screws, or they may be soldered or brazed together. The present invention is not limited to any particular common manufacturing and joining process. Spray module **30** may be placed in direct contact with electronic component, via

the bottom side of spreader **34**, or preferably and shown, a commonly known and used thermal interface material **26** may be placed between. Spray module **30** should have a contact force created by either a mechanical fastener or a spring clip. A spring clip retaining method is described by U.S. Pat. No. 6,166,907. As previously described, there are many different styles of socket **25**, each with their own retention method. It should be appreciated that spray module **30** may include features necessary for being retained. Because retaining methods have been used with air cooled heatsinks for years they are widely understood in the art, and thus will not be described in further detail.

**[0033]** Cap **32** contains at least one inlet **36** which connects to tube system **18**. Pressurized cooling fluid enters inlet **36** and moves into a fluid manifold **44** created between cap **32** and a manifold wall **45** of housing **33**. Contained by manifold wall **45** is an atomizer **31**, preferably a pressure swirl atomizer. Atomizer **31** may be inserted into manifold wall **45**, or fabricated within. U.S. Pat. No. 5,860,602 and U.S. Pat. No. 6,016,969 describe the geometry and a method for producing a pressure swirl atomizer. Fluid manifold **44** delivers a supply of high pressure coolant to atomizer **31**. It should also be appreciated that fluid manifold **44** may support more than one atomizer **31**. Alternatively, the fluid may be brought from inlet **36** directly to atomizer **31** via a direct connection between it and tube system **18**.

**[0034]** Atomizer **31** breaks up the supply of coolant into a wide area spray of droplets. Typically, the droplets will have diameters of 10 – 200 microns and

have velocities of 5 – 50 meters per second. As described by the dissertation by Tilton, optimally the liquid droplets will impinge the cooling surface in a fashion that creates a very high heat flux evaporative thin film. Rather than use wide area high heat flux cooling, as described by U.S. Pat. No. 5,220,804, the present invention creates a localized very high heat flux cooling zone.

**[0035]** Very high heat flux cooling is created through the use of a spray pin **35** inserted or formed into spreader **34**. Preferably, spray pin **35** and spreader **34** are made from a highly conductive material such as copper. The location of spray pin **35** is in close proximity to hotspot **22** of the electronic component. The atomizer **31** dispenses liquid onto the top surface of spray pin **35** which creates an evaporative thin-film **40**. The energy absorbed by thin-film **40** removes heat from spray pin **35** which removes heat from its local areas. The localized areas around spray pin **35** then absorb thermal energy from hotspot **22**.

**[0036]** As shown by Figure 6, excess liquid from spray pin **35** flows onto the top surface of spreader **34** and creates a thick-film **41**. Thick-film **41** may be partially or completely vaporized by the top surface of spreader **34** which cools the non-hotspot areas of the electronic component. Excess amounts of thick-film **41** and vapor exits spray module **30** via an exit **37** connected to tube system **18**. The excess amounts of thick-film **41** and vapor is then delivered to heat exchanger **16**.

**[0037]** The height of spray pin **35** above the top surface of spreader **34** is a design variable. It has been found that a protrusion height of 0.005 inches has

created the needed isolation between thin-film **40** and thick-film **41**, using water as the cooling fluid. It is predicted that the spray pin **35** may be as tall as 0.050 inches or taller, but excessive height of spray pin **35** creates undesirable conduction losses. The thickness and shape of spreader **34** is also a design variable. It may be planar or have a variable thickness; each potentially providing optimal thermal spreading performance for a particular application.

**[0038]**       Wherein the non-hotspot areas of electronic component **20** may have heat fluxes in the range of tens of watts per square centimeter, thin-film **40** on spray pin **35** may produce heat removal rates of several hundreds of watts per square centimeter to several thousand watts per square centimeter. Shown in Figure **10**, testing has provided a correlation between the diameter of spray pin **35** and the heat absorption rate of thin-film **40**. Testing was performed with water sub-cooled by 7 to 14 degrees below its saturation point, and atomizer **31** contained a center jet diameter of .021 centimeters and was placed above spray pin **35** a distance of 1.65 centimeters. The height of 1.65 centimeters was chosen due to system constraints of the test apparatus. It is predicted that a smaller distance will allow thin-film **40** to absorb even larger heat fluxes. It should be appreciated that spray pin **35** may be sized according to a desired heat flux.

**[0039]**       Still referring to Figure **10**, the test data supports the significant functional improvements of the present invention. Spray pin **35** with a diameter of 0.45 centimeters produces a heat flux of 1475 watts per centimeter squared.



This equates to a net heat removal rate of 233 watts. The large heat removal rates may be localized over hotspot **22** through the use of spray pin **35**. The isolation of spray onto spray pin **35** yield benefits over wide area spraying. Because only one atomizer **31** is required, the system can also be produced at a lower cost than wide area spraying.

**[0040]** Other embodiments of the present invention are possible. Figure 7, shows a vapor management protrusion **38** surrounding atomizer **31** which circulates vapor within spray module **30** and over thin-film **40**. Vapor management protrusion **38** helps draw liquid off of the spray fin and may result in even higher heat fluxes. It is predicted that vapor management protrusion **38** should be spaced between 1/2 and 3/4 millimeters from thin-film **40** and should allow for vapor recirculation with module **30**.

**[0041]** In another embodiment shown in Figure 8, spreader **34** may contain more than one spray pin **35**. This allows further control of heat fluxes and the ability to cool multiple hotspots. Also represented in Figure 8, spray pin **35** is not limited to any particular shape. A spherical version is shown. Other shapes are possible, such as angled cylinders, cubes and tetrahedrals.

**[0042]** Figure 8 also shows an array of grooves **39** within spreader **34**. As previously mentioned for single-phase cooling, increasing the contact area between the cooling fluid and the surface to be cooled increases the heat transfer rate. Thus, grooves **39** increase the heat removal rates over the non-heat flux zones. In addition, they also provide the ability to channel liquid to exit

37. It should also be appreciated that surface enhancements may be placed on the top surface of spray pin 35.

[0043] As yet another embodiment within the spirit and scope of the present invention, secondary nozzles may be employed as described by aforementioned co-pending U.S. Patent Application entitled "Hotspot Spray Cooling". The function of the secondary nozzles are to further supply cooling fluid to thick-film 41, as warranted.

[0044] While the hot spot cooling system herein described constitute preferred embodiments of the invention, it is to be understood that the invention is not limited to these precise form of assemblies, and that changes may be made therein with out departing from the scope and spirit of the invention. For example, the benefits of the present invention may be applied to a pin constructed from copper deposited directly on a chip surface. The cooling surface would serve as both spreader 34 and as a base to module 30.

## ELEMENTS BY REFERENCE NUMBER

| #  | NAME                       |    |                             |
|----|----------------------------|----|-----------------------------|
| 1  |                            | 30 | Spray Module                |
| 2  |                            | 31 | Atomizer                    |
| 3  |                            | 32 | Cap                         |
| 4  |                            | 33 | Housing                     |
| 5  |                            | 34 | Spreader                    |
| 6  |                            | 35 | Spray Pin                   |
| 7  |                            | 36 | Inlet                       |
| 8  |                            | 37 | Exit                        |
| 9  |                            | 38 | Vapor Management Protrusion |
| 10 | Spray Cooling System       | 39 | Grooves                     |
| 11 |                            | 40 | Thin-film                   |
| 12 | Pump                       | 41 | Thick-film                  |
| 13 |                            | 42 |                             |
| 14 |                            | 43 |                             |
| 15 |                            | 44 | Manifold                    |
| 16 | Heat Exchanger             | 45 | Manifold Wall               |
| 17 |                            |    |                             |
| 18 | Tube System                |    |                             |
| 19 |                            |    |                             |
| 20 | Electronic Component       |    |                             |
| 21 |                            |    |                             |
| 22 | Hotspot                    |    |                             |
| 23 |                            |    |                             |
| 24 | Substrate                  |    |                             |
| 25 | Socket                     |    |                             |
| 26 | Thermal Interface Material |    |                             |
| 27 |                            |    |                             |
| 28 |                            |    |                             |
| 29 |                            |    |                             |